

INFORMATION CITED BY APPLICANTS THAT MAY BE MATERIAL TO THE
PROSECUTION OF THE SUBJECT APPLICATION

Applicants: D.T. Schwartz et al. Attorney Docket No.: UWOTL127258
Application No.: TO BE DETERMINED
Filed: TO BE DETERMINED
Title: ELECTROCHEMICAL MICROMANUFACTURING SYSTEM AND
METHOD

U.S. PATENT DOCUMENTS

*Examiner Initials	Cite No.	Document No.	Kind Code	Date (mm/dd/yyyy)	Name
	U1	5,641,391	A	06/24/1997	Hunter et al.
	U2	6,027,630	A	02/22/2000	Cohen
	U3	6,080,288	A	06/27/2000	Schwartz et al.
	U4	6,390,610	B1	05/21/2002	Hawkins et al.

FOREIGN PATENT DOCUMENTS

*Examiner Initial	Cite No.	Document No.	Kind Code	Publication Date (mm/dd/yyyy)	Country	English Abstract Provided	Translation Provided
None							

OTHER INFORMATION

(Including Author, Title, Date, Pertinent Pages, Etc.)

*Examiner Initial	Cite No.
None	

None

Examiner

Date Considered

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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